

Notice of References Cited	Application/Control No. 10/065,207	Applicant(s)/Patent Under Reexamination IWAMURA, RYUICHI	
	Examiner Ba Huynh	Art Unit 2179	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-2002/0035579	03-2002	Wang et al.	707/513
	B	US-5,353,398	10-1994	Kitahara et al.	715/759
	C	US-5,793,366	08-1998	Mano et al.	715/839
	D	US-6,272,672	08-2001	Conway, Melvin E.	717/107
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.